

pplicant:

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Serial Number:

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For:

METHOD AND APPARATUS FOR MAINTAINING MASK STRAND

SPATIAL UNIFORMITY

Art Unit:

2879

Examiner:

Jason R. Phinney

AMENDMENT

Box Non Fee Amendment Hon. Assistant Commissioner for Patents Washington, D.C. 20231

Sir:

on Fee Amendment
Assistant Commissioner for Patents
ington, D.C. 20231

This is in response to the Official Action of October 24, 2002, which has a threemonth shortened statutory period for reply ending January 24, 2002.

Please enter the following amendments and remarks.

<u>"Version without Markings"</u>

IN THE SPECIFICATION

Please replace the full paragraph beginning on page 2, line 4 with the following:

The present invention provides a method and apparatus for maintaining uniform spacing between the strands of a tension mask frame. The apparatus includes providing a set of barrier ridges and affixing them to a tension mask. The barrier ridge is aligned perpendicular to the strands of the tension mask and affixed to the frame near the ends of the tension mask. The barrier ridges traverse the length of the tension mask and act to keep the mask strands parallel and equidistantly spaced from each other when faced with applied stress during mask welding and subsequent thermal

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